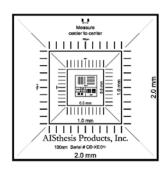
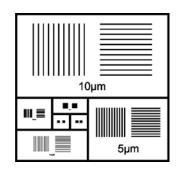


Advanced Imaging Products for Nanotechnology, Engineering and Life Sciences

Certificate of Calibration for Pelcotec™ XY-Critical Dimension Standard





Product Number: Pelcotec™ 690-01 CDMS-XY-0.1C

<u>Product Description:</u> 2.5x2.5mm **Pelcotec™** 2mm-100nm XY-Critical Dimension Magnification Standard

Product Serial Number: CD-XE01-0000

Manufactured for and distributed by:



The accuracy of these products was determined by reference comparison to working standards traceable to the National Institute of Standards and Technology (NIST).

Line	Direction	Certified	Number of	Cartified distance between	Total expanded				
		average pitch	lines averaged	first and last line (1σ)	uncertainty (3σ)				
2.0mm	X	2.00 mm	2	2.00 mm ± 0.03%	± 0.09%				
1.0mm	X	1.00 mm	2	1.00 mm ± 0.03%	± 0.09%				
0.5mm	X	0.500 mm	2	0.500 mm ± 0.03%	± 0.09%				
0.10mm	X	100.00 μm	11	1.00 mm ± 0.03%	± 0.09%				
50µm	X	50.00 μm	112	0.500 mm ± 0.03%	± 0.09%				
10µm	X	10.00 μm	(1) Y	100.00 μm ± 0.03%	± 0.09%				
5µm	X	5.00 µm	9	55.01 μm ± 0.03%	± 0.09%				
2µm	X	2.00 µm	16	30.00 μm ± 0.03%	± 0.09%				
1µm	Χ	1.00 µm	1,7	16.03 μm ± 0.03%	± 0.09%				
500nm	Χ	501.0 nm	20	9.52 µm ± 0.03%	± 0.09%				
250nm	Χ	250.8 nm 🔏	21	5.03 µm ± 0.03%	± 0.09%				
100nm	Χ	100.3 nm	52	5.12 µm ± 0.03%	± 0.09%				
2.0mm	Υ	2.00 min	2	2.00 mm ± 0.03%	± 0.09%				
1.0mm	Υ	1.00 m	2	1.00 mm ± 0.03%	± 0.09%				
0.5mm	Y	0.500 mi.	2	0.500 mm ± 0.03%	± 0.09%				
0.10mm	Y	100.00 um	11	1.00 mm ± 0.03%	± 0.09%				
50µm	Υ	50.00 µm	11	0.500 mm ± 0.03%	± 0.09%				
10µm	Υ	-00 μm	11	100.00 μm ± 0.03%	± 0.09%				
5µm	Y	5.00 μm	12	55.01 μm ± 0.03%	± 0.09%				
2µm	Y	≥2.00 µm	16	30.00 μm ± 0.03%	± 0.09%				
1µm	Y	→ 1.00 µm	17	16.03 μm ± 0.03%	± 0.09%				
500nm	\	501.0 nm	20	9.52 µm ± 0.03%	± 0.09%				
250nm	X)'	250.8 nm	21	5.03 µm ± 0.03%	± 0.09%				
100nm		100.3 nm	52	5.12 µm ± 0.03%	± 0.09%				

The certified average pitch is derived from the stated certified length that was determined using 10 measurements (taken center-to-center) over the stated number of lines (i.e., length divided by the number of lines minus one). The total expanded uncertainty includes both Type A and Type B uncertainties corrected for sample size using an appropriate Student t-factor.

Equipment used:

Instrument	Model number	Serial #	NIST Certified CD/Recalibration	Resolutio	Repeatability
FE-SEM	FEI Verios	9922551	CD-PG01-0211/June 2018	0.9nm	0.03%
Certified by		Signature		Date	

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